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## The 3C-6H polytypic transition in SiC as revealed by diffuse x-ray scattering

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The 3C-6H polytypic transition in SiC single crystals is studied by means of diffuse x-ray scattering. Based on numerical simulations of the diffuse scattering intensity distribution we unambiguously prove that the 3C-6H transition in SiC occurs through the glide of partial dislocations and not by the “layer displacement” mechanism (i.e., local diffusional rearrangement of the Si and C atoms). The technique is extremely sensitive and can be used as a nondestructive mean to obtain statistically relevant values of the transition level down to  $\sim 0.05\%$ . © 2009 American Institute of Physics. [DOI: 10.1063/1.3141509]

Cubic silicon carbide (3C-SiC) is a wide-band-gap semiconductor of high interest for high power, high frequencies, and harsh environments operating devices. Important efforts have therefore been directed to optimizing the growth conditions of 3C-SiC films,<sup>1</sup> characterizing their electronic<sup>2</sup> and structural<sup>3,4</sup> properties. However, despite decades of studies, the crystalline quality of 3C-SiC single crystals is too poor to allow their effective integration in electronic devices. Bulk growth of high quality 3C-SiC ingots still is an issue as the high temperatures required to grow SiC ( $>1900$  °C) usually promote the solid-state 3C-6H polytypic transition through the formation of a large number of planar defects (mainly stacking faults, SFs).<sup>5</sup> Even if recent attempts could pave the way of 3C-SiC bulk growth,<sup>6</sup> a thorough study of such a transition is one of the key for a real development of 3C-SiC material.

Up until now, the mechanism involved in the 3C-6H transition in SiC single crystals is still not clearly identified. This question has been first tackled by Jagodzinski<sup>7</sup> and Krishna and Marshall<sup>8</sup> both using x-ray diffraction photographs. Both studies concluded that the transition occurs in the solid-state through a “layer displacement” mechanism where two 3C sequences,  $ABCA[BC]$ , are transformed into a 6H sequence,  $ABCA[CB]$ , by local diffusional rearrangement of the Si and C atoms in the two last layers (indicated by the square brackets). Contradictory results have been obtained by Pirouz and Young<sup>9</sup> using high-resolution transmission electron microscopy. They suggested that the transformation occurs through the glide of partial dislocations, so that the initial regular stacking is successively transformed into  $ABCA|CA$  and  $ABCAC|B$  (the stacking fault associated with the partial is indicated by the bar). The 3C-6H transition in SiC single crystals has also been investigated using Raman scattering,<sup>10</sup> although no direct information regarding the transformation mechanism could be obtained by this technique. In this letter we report on high-resolution diffuse x-ray scattering (DXS) experiments performed on 3C-SiC single crystals undergoing the 3C-6H polytypic transition. First, with the aid of numerical simulations, we show that the

analysis of experimental DXS intensity distributions allows an unambiguous determination of the mechanism involved in the 3C-6H transition. Second, contrarily to the techniques mentioned above, we demonstrate that the quantitative comparison of experimental DXS profiles with numerical simulations allows to straightforwardly obtain the transformation level.

In the present study, three different samples are analyzed. All crystals are  $10 \times 10$  mm<sup>2</sup>, 250- $\mu$ m-thick, (001)-oriented 3C-SiC provided by HAST Corporation. The first sample (sample 1) is a high quality (i.e., untransformed) 3C-SiC crystal. Sample 2, is a low quality sample where the 3C-6H transition occurred during crystal growth. Finally, sample 3 is of the same type than sample 2 and has been annealed at 1700 °C during 5 h in order to promote the transformation. DXS experiments were conducted on a laboratory equipment mounted on a high power x-ray source coupled with a four reflections Ge(220) monochromator and equipped with a curved position sensitive detector (PSD).<sup>11</sup> The x-ray beam is 100  $\mu$ m thick and 10 mm wide. Maps of the scattered intensity including the (002) and (113) reflections of 3C-SiC were recorded for each sample (Fig. 1). A schematic representation of the scattering geometry and the area scanned in the reciprocal space is shown in Fig. 1(f).

The map corresponding to sample 1 [Fig. 1(a)] exhibits two intense and narrow spots corresponding to the (002) and (113) reflections of 3C-SiC. The magnification of the (002) reflection [Fig. 1(d)] reveals that the reflections are streaked along directions making an angle  $\psi \approx 55^\circ$  with the  $[001]_c$  direction (the subscript *c* stands for cubic), which is the signature of the presence of SFs lying in the  $\{111\}$  planes ( $\psi_{(111),(001)} = 54.74^\circ$ ). The streaks are symmetric with respect to the center of the reflection and their intensity is relatively weak which indicates a low density of randomly distributed SFs.<sup>4</sup> On the contrary, in the map corresponding to sample 2 [Figs. 1(b) and 1(e)] the streaks extend throughout wide regions of the reciprocal space and their intensity is much more pronounced. Finally, in the map corresponding to sample 3 [Fig. 1(c)] there is an intense and inhomogeneous streak of diffuse intensity joining the (002) and the (113) reflections. In terms of the equivalent hexagonal axes<sup>12</sup> (i.e.,

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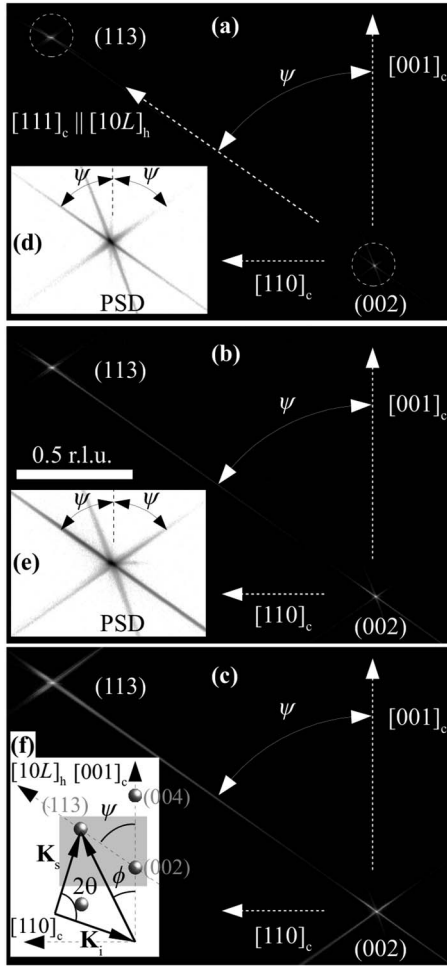


FIG. 1. Reciprocal space maps including the (002) and (113) reflections of 3C-SiC corresponding to sample 1 (a), sample 2 (b), and sample 3 (c). The scale bar, shown in (b), is given reciprocal lattice units (i.e., in units of  $hkl$ ). For sample 1 the reflections are indicated by the dashed circles. Insets (d) and (e) are  $12\times$  magnifications in reversed contrast of the (002) reflection evidencing the diffuse streaks. The streak labeled “PSD” is due to the transmittance function of the PSD. In all cases the intensity is plotted logarithmically. Inset (f) is a schematic representation of the scattering geometry. The area scanned in reciprocal space is shown as the gray rectangle and the spheres correspond to the reflections of 3C-SiC.  $\mathbf{K}_i$  and  $\mathbf{K}_s$  are the wave vectors of the incident and the scattered radiation.

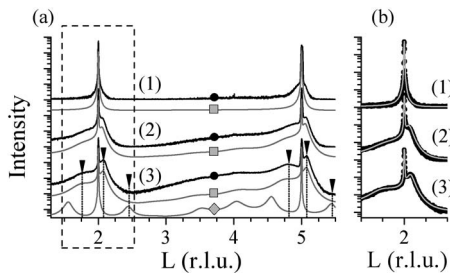


FIG. 2. (a) Intensity distribution along the  $[10L]_h$  row. The labels (1–3) correspond to sample 1–3, respectively. The black curves (black circles) correspond to the experimental data. The gray curves are the calculated intensity profiles with the dislocation-based model (squares) and the layer displacement model (diamond). The curves are shifted vertically for clarity. The dashed arrows indicate features in the diffuse scattering structure that are perfectly reproduced with the dislocation-based model and that the layer displacement model fails to reproduce. (b) Enlarged view of the  $L = 1.5\text{--}2.5$  region evidencing the quality of the simulation (black circles: experimental data; gray line: simulation with the dislocation model).

$[001]_h \parallel [111]_c$  and  $[100]_h \parallel [-110]_c$ ) the streak direction corresponds to the  $[10L]_h$  direction, where  $L=2$  and  $L=5$  for the (002) and (113) reflections, respectively. The increase in the DXS intensity together with its inhomogeneous character suggests a high density of planar defects that are nonrandomly distributed throughout the crystal, i.e., the 3C-SiC crystal is probably partly transformed.

The intensity distribution in the diffuse streak [black curves, Fig. 2] clearly shows an increase in the DXS intensity as well as an inhomogeneous distribution of this intensity when moving from sample (1) to sample (3). These profiles have been interpreted with the help of numerical simulations of the scattered intensity. It must be emphasized that when  $L$  is varied from 1.5 to 5.5, the corresponding  $2\theta$  angle spans an  $\sim 42^\circ$  range so that all  $\theta$ -dependent terms have to be correctly taken into account. In the framework of the kinematical scattering theory<sup>12</sup> the intensity distribution along the  $[10L]_h$  row can be written

$$I(L) = k \delta V(\theta) L(\theta) P(\theta) \int dL' R(L') I_s(L-L') + b, \quad (1)$$

where the scale factor  $k$  and the background  $b$  are constants for a given set of experimental conditions (incident beam intensity, counting time, etc.).  $\delta V(\theta)$  is the variation of the irradiated volume during the experiment, and writes  $\sin(\theta + \phi) / [\sin(\theta + \phi) + \sin(\theta - \phi)]$ , where  $\phi$  is the angle between  $[001]$  and any point along the  $[10L]_h$  row [see Fig. 1(f)].  $L(\theta) = 1/\sin 2\theta$  is the Lorentz factor and  $P(\theta)$  is the polarization factor, which, using a four reflections Ge(220) monochromator, can be written  $(1 + \cos^8 \theta_{\text{Ge}(220)} \cos^2 \theta) / 2$ .  $R(L)$  is the resolution function of the diffractometer. In the present case it has the shape of a Gaussian function the width of which can be precisely evaluated.<sup>11</sup> Finally,  $I_s(L)$  is the intensity scattered from the sample. This term contains the information regarding the stacking sequence in the crystal and is therefore sensitive to the mechanism involved in the transition.

Within the formalism of Kabra *et al.*<sup>13</sup> the intensity distribution along the  $[10L]_h$  row in a partly transformed crystal can be written

$$I_s(L) = C |f_0|^2 I_c + 2(1-C) |f_0|^2 \times \Re \left\{ \frac{1}{2} + \frac{\sum_{n=1}^{N-1} \sum_{m=0}^{n-1} a_{N-m} J_{n-m} \exp[-2\pi i(N-n)L/3] - a_0 J_0}{\sum_{n=0}^N a_n \exp[-2\pi i n L/3]} \right\}. \quad (2)$$

The first term on the right-hand side of Eq. (2) is the coherent part of the scattered intensity, the intensity of which is modulated by a Debye–Waller–like factor ( $C \in [0, 1]$ ) which depends on the faulting structure and the defect density. The coherent intensity  $I_c$  depends on the size and shape of the crystalline domains over which diffraction is coherent (mosaic domains).<sup>14</sup> It turned out that finite size effects could be safely neglected here, so that in the following the mosaic domains have been assimilated to cubes with dimensions ( $6 \mu\text{m}$ ) much larger than the diffractometer coherence length.  $f_0$  is the structure factor of a single “SiC” layer. The second term on the right-hand side of Eq. (2) is the diffuse scattering due to the presence of faults. Both  $J_m$  (the pair

correlation function) and  $a_n$  (the coefficients of the “characteristic equation”) can be calculated analytically assuming a certain transition mechanism and therefore a particular faulting structure. For the dislocation-based mechanisms it comes  $C=0$ ,  $N=6$ ; the expression of  $J_m$  and  $a_n$  are given in Ref. 13 (p. 1657) and solely depends on the transformation level,  $\tau$ . For the layer displacement mechanism,  $C=[(1+2\tau)/(1+5\tau)]^2$  and  $N=5$ . The expressions of  $J_m$  and  $a_n$  are not given in Ref. 13. We derived the coefficients and obtained  $\tau\omega^2$ ,  $\tau\omega$ ,  $\tau$ ,  $\tau\omega^2$ ,  $\tau\omega$  and 1 for  $a_0$  to  $a_5$ , respectively [ $\omega=\exp(2\pi i/3)$ ]. For  $J_m$  we obtained  $J_0=[6\omega^2\tau+3\tau^2(1+\omega+8\omega^2)]/D$ ,  $J_1=[-3\omega^2\tau+3\tau^2(\omega-4\omega^2-2)]/D$ ,  $J_2=[3\tau^2(1-\omega)^2]/D$ ,  $J_3=[3\tau^2(1+\omega-2\omega^2)]/D$ ,  $J_4=[3\tau^2(\omega+\omega^2-2)]/D$ , and  $D=\omega^2(1+5\tau^2)$ .

An important assumption made in deriving Eq. (2) is that the whole crystal is transformed *simultaneously*. However, considering the very large lateral dimensions of the crystals ( $10\times 10$  mm<sup>2</sup>) this is very unlikely to happen. Moreover this assumption is contradictory with the analysis of the transformation using Raman scattering<sup>10</sup> which proved that the transformation is initiated at the surface and then propagates into the crystal volume. In the volume probed with the x-ray beam both transformed and untransformed areas certainly coexist so that we finally write the intensity scattered from the sample as

$$I_s = x_t I_t + (1 - x_t) I_c, \quad (3)$$

where  $x_t$  is the volume fraction of transformed material.

The best simulation results [using Eqs. (1)–(3)] obtained for the dislocation-based model (square) and the layer displacement model (diamond) are shown in Fig. 2. Let us first consider the data corresponding to sample 3. The major result of this analysis is that the dislocation-based model fits the DXS intensity distribution over the whole investigated  $L$ -range. On the contrary, the layer displacement model clearly fails to reproduce the observed data. This simple result provides an unambiguous proof that the 3C-6H transition occurs through the glide of partial dislocations and not by local diffusional rearrangement of the Si and C atoms. The relevance of this result can be attested by the inspection of the enlarged view of the (002) reflection [Fig. 2(b)]: the model perfectly fits the data over approximately four orders of magnitude whereas there are only two fitting parameters (the transformation level  $\tau$  and the volume fraction  $x_t$ ) for the whole angular range considered. It must be emphasized that although the same theoretical basis is used, this result is opposite to the conclusions of Kabra *et al.*<sup>13</sup> This discrepancy can be explained by the fact that their study was based on the

analysis of x-ray photographs. This prevented them to access the fine structure of the diffuse scattering which is yet mandatory to clearly distinguish the different mechanisms [see Fig. 2(a), sample 3]. The overall transformation level  $\tau\times x_t$  is straightforwardly obtained from the simulation procedure. We obtain 0.05%, 1.6%, and 4.3% for sample 1–3, respectively, which shows that even a very low transformation level produce significant effects in terms of diffuse scattering.

In summary, the interpretation of the diffuse x-ray scattering allowed us to prove unambiguously that the 3C-6H transition in SiC occurs through the glide of partial dislocations. Moreover, this method is non destructive and provides averaged, statistically relevant measurements the transition level. A detailed knowledge of this polytypic transition in SiC will be of great help for the development of high quality and high performance 3C-SiC materials and devices.

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<sup>1</sup>A. Fissel, B. Schröter, U. Kaiser, and W. Richter, *Appl. Phys. Lett.* **77**, 2418 (2000).

<sup>2</sup>A. Fissel, W. Richter, J. Furthmüller, and F. Bechstedt, *Appl. Phys. Lett.* **78**, 2512 (2001); K.-B. Park, Y. Ding, J. P. Pelz, P. G. Neudeck, and A. Trunek, *ibid.* **89**, 042103 (2006); M. V. S. Chandrashekhara, C. I. Thomas, J. Liu, and M. G. Spencer, *ibid.* **91**, 033503 (2007).

<sup>3</sup>M. Zielinski, A. Leycuras, S. Ndiaye, and T. Chassagne, *Appl. Phys. Lett.* **89**, 131906 (2006); C. Coletti, C. L. Frewin, S. E. Sadow, M. Hetzel, C. Virojanadara, and U. Starke, *ibid.* **91**, 061914 (2007); R. Anzalone, C. Bongiorno, A. Severino, G. D’Arrigo, G. Abbondanza, G. Foti, and F. La Via, *ibid.* **92**, 224102 (2008).

<sup>4</sup>A. Boulle, D. Chaussende, L. Latu-Romain, F. Conchon, O. Masson, and R. Guinebrière, *Appl. Phys. Lett.* **89**, 091902 (2006).

<sup>5</sup>N. W. Jepps and T. F. Page, *Prog. Cryst. Growth Charact.* **7**, 259 (1983).

<sup>6</sup>D. Chaussende, F. Mercier, A. Boulle, F. Conchon, M. Soueidan, G. Ferro, A. Mantzari, A. Andreadou, E. K. Polychroniadis, C. Balloud, S. Juillaguet, J. Camassel, and M. Pons, *J. Cryst. Growth* **310**, 976 (2008).

<sup>7</sup>H. Jagodzinski, *Kristallogr.* **16**, 1235 (1971).

<sup>8</sup>P. Krishna and R. C. Marshall, *J. Cryst. Growth* **11**, 147 (1971).

<sup>9</sup>P. Pirouz and J. W. Yang, *Ultramicroscopy* **51**, 189 (1993).

<sup>10</sup>W. S. Yoo and H. Matsunami, *J. Appl. Phys.* **70**, 7124 (1991); R. Püschel, M. Hundhausen, L. Ley, K. Semmelroth, F. Schmid, G. Pensl, and H. Nagasawa, *ibid.* **96**, 5569 (2004).

<sup>11</sup>A. Boulle, O. Masson, R. Guinebrière, A. Lecomte, and A. Daurer, *J. Appl. Crystallogr.* **35**, 606 (2002).

<sup>12</sup>B. E. Warren, *X-ray Diffraction* (Addison-Wesley, New-York, 1969), pp. 46 and 258.

<sup>13</sup>V. K. Kabra, D. Pandey, and S. Lele, *J. Mater. Sci.* **21**, 1654 (1986).

<sup>14</sup>A. Boulle, R. Guinebrière, and A. Daurer, *J. Phys. D: Appl. Phys.* **38**, 3907 (2005).